

Report Documentation Page			Form Approved OMB No. 0704-0188		
Public reporting burden for the collection of information is estimated to average 1 hour per response, including the time for reviewing instructions, searching existing data sources, gathering and maintaining the data needed, and completing and reviewing the collection of information. Send comments regarding this burden estimate or any other aspect of this collection of information, including suggestions for reducing this burden, to Washington Headquarters Services, Directorate for Information Operations and Reports, 1215 Jefferson Davis Highway, Suite 1204, Arlington VA 22202-4302. Respondents should be aware that notwithstanding any other provision of law, no person shall be subject to a penalty for failing to comply with a collection of information if it does not display a currently valid OMB control number.					
1. REPORT DATE <b>28 JUN 2006</b>		2. REPORT TYPE <b>Technical, Success Story</b>		3. DATES COVERED <b>18-09-2005 to 28-06-2006</b>	
4. TITLE AND SUBTITLE <b>Reduce Manufacturing Costs of Ultra-High Temperature Rhenium Pintle/Throat Combinations</b>			5a. CONTRACT NUMBER		
			5b. GRANT NUMBER		
			5c. PROGRAM ELEMENT NUMBER		
6. AUTHOR(S)			5d. PROJECT NUMBER <b>05-0073-10</b>		
			5e. TASK NUMBER		
			5f. WORK UNIT NUMBER		
7. PERFORMING ORGANIZATION NAME(S) AND ADDRESS(ES) <b>National Center for Defense Manufacturing &amp; Machining,1600 Technology Way,Latrobe,PA,15650</b>			8. PERFORMING ORGANIZATION REPORT NUMBER		
9. SPONSORING/MONITORING AGENCY NAME(S) AND ADDRESS(ES)			10. SPONSOR/MONITOR'S ACRONYM(S)		
			11. SPONSOR/MONITOR'S REPORT NUMBER(S)		
12. DISTRIBUTION/AVAILABILITY STATEMENT <b>Approved for public release; distribution unlimited</b>					
13. SUPPLEMENTARY NOTES					
14. ABSTRACT <b>Controllable thrust propulsion for the next generation of tactical missiles (NLOS PAM) is providing significant mission flexibility and increasing the system capability with precision performance. Thrust propulsion within a tactical missile is controlled by a pintle/throat configuration. The purpose of the pintle/throat configuration is to maximize the thrust within the rocket motor to successfully propel the missile. Rhenium, due to its high thermal and mechanical properties, is the best acceptable, high-temperature, and corrosion resistant material for managed-energy tactical propulsion systems. The NCDMM, along with Plasma Processes, Inc. (PPI), and the Aviation and Missile Research, Development, and Engineering Center (AMRDEC), have been requested to optimize the manufacturing process in order to reduce the cost of the pintle/throat combinations. This will be accomplished by replacing solid rhenium with rhenium coatings fabricated by Plasma Processes' El-Form electrodeposition process.</b>					
15. SUBJECT TERMS <b>NCDMM; Plasma Processes, Inc.; Aviation and Missile Research, Development, and Engineering Center; AMRDEC; Success Stories</b>					
16. SECURITY CLASSIFICATION OF:			17. LIMITATION OF ABSTRACT <b>1</b>	18. NUMBER OF PAGES <b>1</b>	19a. NAME OF RESPONSIBLE PERSON
a. REPORT <b>unclassified</b>	b. ABSTRACT <b>unclassified</b>	c. THIS PAGE <b>unclassified</b>			

# Reduce Manufacturing Costs of Ultra-High Temperature Rhenium Pintle/Throat Combinations

NCDMM Project No. 05-0073-10

## PROBLEM / OBJECTIVE

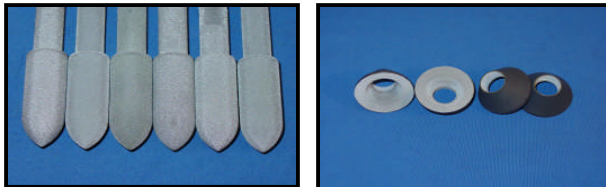
Controllable thrust propulsion for the next generation of tactical missiles (NLOS PAM) is providing significant mission flexibility and increasing the system capability with precision performance. Thrust propulsion within a tactical missile is controlled by a pintle/throat configuration. The purpose of the pintle/throat configuration is to maximize the thrust within the rocket motor to successfully propel the missile. Rhenium, due to its high thermal and mechanical properties, is the best acceptable, high-temperature, and corrosion resistant material for managed-energy tactical propulsion systems.

The NCDMM, along with Plasma Processes, Inc. (PPI), and the Aviation and Missile Research, Development, and Engineering Center (AMRDEC), have been requested to optimize the manufacturing process in order to reduce the cost of the pintle/throat combinations. This will be accomplished by replacing solid rhenium with rhenium coatings fabricated by Plasma Processes' EI-Form™ electrodeposition process.

## ACCOMPLISHMENTS / PAYOFF

### Process Improvement

In a previous effort, PPI had successfully machined the pintles and throats from lightweight graphite substrates. Utilizing their EI-Form™ rhenium deposition process, PPI successfully coated these graphite pintles and throats with a rhenium coating in several thicknesses for testing.



Rhenium Coated Graphite Pintles/Throats

During previous "Hot Fire" testing (several iterations of boost and sustain cycles) of the pintle/throat combinations, a minimum thickness of rhenium coating for the throat was established. However, a minimum thickness of rhenium coating for the pintle was not.

The NCDMM, PPI, and AMRDEC were successful in optimizing the processes to achieve the goal of producing lightweight rhenium coated pintle/throat combinations with a 90% reduction in costs. The following goals were accomplished to make the 90% cost reduction possible:

- Selection of pintle/throat size and geometry
- Determination of minimum coating thickness per component
- Increase deposition rates
- Reduce/eliminate post-deposition machining
- Optimize manufacturing processes to increase throughput per run

### Implementation and Technology Transfer

With an initial capital investment of \$950K, production of the pintle/throat combinations can be increased from 1,000 combinations per year to 3,000 combinations per year. In addition to the increased capacity and significant cost reduction, an 80% reduction in weight per combination will be achieved.

### Expected Benefits

Plasma Processes, Inc. has estimated a cost savings/cost avoidance of \$6,100 per pintle/throat combination utilizing the rhenium coating process. The result of this effort will produce an annual cost savings/cost avoidance of \$6.1M per year based on the current production of approximately 1,000 missiles/year. Plasma Processes anticipates increasing production to 3,000 missiles per year, resulting in an estimated \$18.3M per year cost savings/cost avoidance utilizing the efforts of this project.

## TIME LINE / MILESTONE

Start Date.....September 05  
End Date .....June 06

## PROJECT FUNDING

NCDMM Funding.....\$225K

## PARTICIPANTS

Aviation and Missile Research, Development, and Engineering Center (AMRDEC)  
Plasma Processes, Inc.

*For additional information concerning this project, contact the NCDMM at [www.ncdmm.org](http://www.ncdmm.org)*